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OK TO ENTER: /M.L.P./

NO. 8183 P. 2/18

Docket No. 740756-945

01/08/2013

was considered with 11/17/2006 action

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent application:)
Hisato SHINOHARA et al.)
Application Serial No. 08/169,127) Art Unit: 1762
Filed: December 20, 1993) Examiner: Marianne L. Padgett
For: LASER IRRADIATION METHOD) Date: August 25, 2006
(AS AMENDED)

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SUPPLEMENTAL AMENDMENT

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Sir:

Further to the Amendment filed June 27, 2006, please consider the following amendments and remarks in connection with this instant application.

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Commissioner of Patents P.O. Box 1450
Alexandria, VA 22313-1450 or facsimile transmitted to 571-273-8300 on the following date 8/25/06

Patricia L. Patterson

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